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Amendments to the Claims:

This listing of claims replaces all prior versions and listings of claims in the application:

Listing of Claims:

1. (Currently Amended) A carrier head for chemical mechanical polishing, comprising:
a base having at least a portion formed of a polymer;
a mounting assembly connected to the base having a surface for contacting a substrate;
[[and]]
a retainer secured to the portion of the base to prevent the substrate from moving along
the surface; and
a damping material secured between the retainer and the portion of the base to reduce the
translation of vibrational energy between the retainer and the base.
2. (Original) The carrier head of claim 1, wherein the portion of the base is a ring-shaped body extended around a perimeter of the base.
3. Cancelled. ~~The carrier head of claim 2, further comprising a dampening material secured between the retainer and the portion of the base.~~
4. (Currently Amended) The carrier head of claim [[3]]2, wherein the ring-shaped body includes at least one boss extending to contact the ~~retainer retaining ring~~.
5. (Currently Amended) The carrier head of claim 4, further comprising at least one screw extending through apertures in the base, the ring-shaped body and the damping material and into a receiving recess in the ~~retainer retaining ring~~ to secure the ~~retainer retaining ring~~ to the base.

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6. (Currently Amended) The carrier head of claim 5, wherein the at least one boss surrounds the at least one screw.
7. (Currently Amended) The carrier head of claim [[3]]1, wherein the polymer includes polyphenylenesulfide, carbon fibers and polytetrafluoroethylene.
8. (Original) The carrier head of claim 7, wherein the polymer includes about 50-55% polyphenylenesulfide, 30-35% carbon fibers, and about 10-15% polytetrafluoroethylene.
9. (Currently Amended) The carrier head of claim 7, wherein the damping material includes a polyvinylchloride thermoplastic thermoplastic.
10. (Currently Amended) The carrier head of claim [[1]]2, wherein the polymer includes polyphenylenesulfide, carbon fibers and polytetrafluoroethylene.
11. (Original) The carrier head of claim 1, wherein the entire base is formed from the polymer.
12. Cancelled. ~~The carrier head of claim 1, further comprising a dampening material secured between the retainer and the portion of the base.~~
13. (Currently Amended) The carrier head of claim 1, wherein a bottom portion of the retainer includes at least one of carbon, fluoropolymer, [[and]]or polyester.
14. (Currently Amended) A carrier head for chemical mechanical polishing, comprising:
 - a base;
 - a mounting assembly attached to the base having a surface for contacting a substrate;

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a retainer secured to the portion of the base to prevent the substrate from moving along the surface[[,]]; and

a dampeningdamping material secured between the retainer and the base to reduce the translation of vibrational energy between the retainer and the base.

15. (Currently Amended) The carrier head of claim 14, wherein the dampeningdamping material includes at least one of polyurethane [[and]]or polyvinylchloride thermoplastic.

16. (Original) The carrier head of claim 14, wherein the base has at least a portion formed of a polymer and the retainer is secured to the portion of the base.

17. (Original) The carrier head of claim 16, wherein the portion of the base is a ring-shaped body extended around a perimeter of the base.

18. (Currently Amended) The carrier head of claim 17, further comprising at least one screw extending through apertures in the base, the ring-shaped body and the damping material and into a receiving recess in the retainerretaining ring to secure the retainerretaining ring to the base.

19. (Currently Amended) The carrier head of claim 17, wherein the ring-shaped body includes at least one boss surrounding the screw and extending to contact the retainerretaining ring.

20. (Currently Amended) The carrier head of claim 14, wherein a bottom portion of the retainer includes at least one of carbon, fluoropolymer, [[and]]or polyester.

21. (Currently Amended) A carrier head for chemical mechanical polishing, comprising:
a base;
a mounting assembly attached to the base having a surface for contacting a substrate; and

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a retainer secured to the portion of the base to prevent the substrate from moving along the surface, at least a bottom portion of the retainer including a material selected from the group consisting of polytetrafluoroethylene, perfluoroalkoxy, polyethylene terephthalate, polyetheretherketone, polyetherketoneketone, polybenzimidazole, an imidized thermoset polyimide, a semi-crystalline thermoplastic polyester, and a long molecular chain molecule produced from poly-paraphenylene terephthalamide.

22. (Currently Amended) The carrier head of claim 21, wherein the bottom portion of the retainer retaining ring further includes carbon.

23. (Currently Amended) The carrier head of claim 22, wherein the bottom portion of the retainer retaining ring further includes graphite.

24. (Currently Amended) The carrier head of claim 22, wherein the bottom portion of the retainer retaining ring further includes carbon fibers.

25. (Currently Amended) An article for attachment to a carrier head, comprising:
a ring-shaped body configured to be detachably secured at an outer perimeter of a carrier head, the ring-shaped body formed of a polymer and having a plurality of apertures therethrough and a plurality of bosses surrounding the apertures.

26. (Original) The article of claim 25, wherein the polymer includes polyphenylenesulfide, carbon fibers and polytetrafluoroethylene.

27. (Currently Amended) An article for attachment to a carrier head, comprising:
a generally flat annular body configured to be detachably secured at an outer perimeter of a carrier head, the annular body formed of a dampening damping material and having a plurality

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of apertures therethrough, each aperture configured to allow a connector to pass through the article.

28. (Currently Amended) The article of claim 27, wherein the ~~dampening~~^{damping} material includes at least one of polyurethane [[and]]~~or~~ polyvinylchloride thermoplastic.

29. (Currently Amended) A retaining ring for a chemical mechanical polishing head, comprising:

an upper portion configured to be secured to a base;
a bottom portion that includes a material selected from the group consisting of polytetrafluoroethylene, perfluoroalkoxy, polyethylene terephthalate, polyether etherketone, polyetherketoneketone, polybenzimidazole, ~~an imidized thermoset polyimide~~, a semi-crystalline thermoplastic polyester, and a long molecular chain molecule produced from poly-paraphenylene terephthalamide.

30. (Currently Amended) The retaining ring of claim 29, wherein the bottom portion of the retaining ring further includes at least one of graphite [[and]]~~or~~ carbon fibers.